

<b>LIST OF ART CITED BY APPLICANT</b>  <b>(PTO-1449)</b>				ATTY. DOCKET NO. <b>K-0634</b>		APPLN. SERIAL NO. <b>10/824,363</b>	
				APPLICANT(S) <b>Chang Nam KIM</b>			
				FILING DATE <b>April 15, 2004</b>		GROUP <b>2879</b>	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCL ASS	FILING DATE	
	<b>6,111,357</b>	<b>08-29-2000</b>	<b>Fleming et al.</b>				
<b>U.S. PATENT APPLICATION PUBLICATIONS</b>							
	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCL ASS		
<b>U.S. PATENT APPLICATIONS</b>							
	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCL ASS		
<b>FOREIGN PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCL ASS	Translation	
						Yes	No
	<b>JP 2000-021567</b>	<b>01-21-2000</b>	<b>Japan (Full Japanese text and English Abstract)</b>			<b>Abstract Only</b>	
<b>OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)</b>							
	<b>Chinese Office Action dated December 14, 2007.</b>						
EXAMINER				DATE CONSIDERED			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.